

<b>Notice of References Cited</b>	Application/Control No. 09/775,069	Applicant(s)/Patent Under Reexamination MOUROU ET AL.	
	Examiner Geoffrey S Evans	Art Unit 1725	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

#### FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
*	N	JP-62-144,893-A	06-1987	Japan	Nishiwaki et al.	---
	O					
	P					
	Q					
	R					
	S					
	T					

#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
*	U	Kautek et al., "Femtosecond pulse laser ablation of metallic, semiconducting, ceramic, and biological materials", 04/1994, The international Society of for Optical Engineering (SPIE) Volume 2207, pages 600-607,611.
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.